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AMENDMENT TRANSMITTAL LETTER (Large Entity) Applicant(s): Ji-Soo KIM et al.						Docket No. SEC.761D	
Application No.	Filing Date January 30, 2004	Examiner Ram N. KACKAR		Customer N 20987	10.	Group Art Uni 1763	t Confirmation No. 3956
METHOD OF AND APPARATUS FOR MANUFACTURING A SEMICONDUCTOR DEVICE USING A POLYSILICON HARD DISK							
COMMISSIONER FOR PATENTS:							
Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below.							
CLAIMS AS AMENDED							
	CLAIMS REMAINING	HIGHEST #	NUMBE	ER EXTRA		RATE	ADDITIONAL
	AFTER AMENDMENT	PREV. PAID FOR	CLAIMS	PRESENT			FEE
TOTAL CLAIMS	9 -	20 =		0	x	\$50.00	\$0.00
INDEP. CLAIMS	2 -	3 =		0	x	\$200.00	\$0.00
Multiple Dependent Claims (check if applicable)							\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT \$0.00							
No additional fee is required for amendment. ☐ Please charge Deposit Account No. in the amount of ☐ A check in the amount of to cover the filing fee is enclosed. ☐ The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account 50-0238 ☐ Any additional filing fees required under 37 C.F.R. 1.16. ☐ Any patent application processing fees under 37 CFR 1.17. ☐ Payment by credit card. Form PTO-2038. WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038. Signature Dated: June 9, 2006							
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In re PATENT APPLICATION of

Ji-Soo KIM et al.

Art Unit: 1763

Application No. 10/766,932

Examiner: Ram N. KACKAR

Filed: January 30, 2004

Confirmation No.: 3956

For:

METHOD OF AND APPARATUS FOR MANUFACTURING A

SEMICONDUCTOR DEVICE USING A POLYSILICON HARD DISK

AMENDMENT AFTER FINAL

U.S. Patent & Trademark Office Customer Service Window Mail Stop: AF Randolph Building 401 Dulany Street Alexandria VA 22314

Sir:

This is a response to the Office Action made final and dated April 18, 2006. Applicants respectfully request its entry.

Proposed amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.